



Attorney's Docket No.: 12732-171001 / US6695

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Masaharu Nagai et al.                      Art Unit : 1756  
Serial No. : 10/694,986                                      Examiner : Daborah Chacko-Davis  
Filed : October 29, 2003  
Title : METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICE

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REPLY TO ACTION OF OCTOBER 4, 2005

Please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 8.